



## UNITED STATES PATENT AND TRADEMARK OFFICE

**FILE COPY**
 COMMISSIONER FOR PATENTS  
 UNITED STATES PATENT AND TRADEMARK OFFICE  
 WASHINGTON, D.C. 20231  
 www.uspto.gov


Bib Data Sheet

CONFIRMATION NO. 3496

<b>SERIAL NUMBER</b> 09/816,359	<b>FILING DATE</b> 03/26/2001 <b>RULE</b>	<b>CLASS</b> 219	<b>GROUP ART UNIT</b> 3742	<b>ATTORNEY DOCKET NO.</b> 35.C13975 CIP
<b>APPLICANTS</b> Nobumasa Suzuki, Tochigi, JAPAN; Shigenobu Yokoshima, Tochigi, JAPAN;				
<b>** CONTINUING DATA *****</b> THIS APPLICATION IS A CIP OF 09/426,774 10/26/1999 ABN				
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 2000-091709 03/29/2000 JAPAN 10-308836 10/29/1998 JAPAN 11-190400 07/05/1999				
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> <b>** 05/31/2001</b>				
Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature _____ Initials _____	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 16	<b>TOTAL CLAIMS</b> 59
<b>INDEPENDENT CLAIMS</b> 6				
<b>ADDRESS</b> 05514				
<b>TITLE</b> Microwave applicator, plasma processing apparatus having same, and plasma processing method				
<b>FILING FEE RECEIVED</b> 2088	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	

03500.013975.1

PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

NOBUMASA SUZUKI, ET AL.

Application No.: 09/816,359

Filed: March 26, 2001

For: MICROWAVE APPLICATOR,  
PLASMA PROCESSING  
APPARATUS HAVING SAME,  
AND PLASMA PROCESSING  
METHOD

)  
:  
Examiner: Unassigned

)  
:  
Group Art Unit: 3742

)  
:  
April 4, 2002

The Commissioner for Patents  
Washington, D.C. 20231

RECEIVED  
APR 12 2002  
TECHNOLOGY CENTER 3700

REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT

Sir:

Applicants are in receipt of an Official Filing Receipt in the above-identified application. The Official Filing Receipt incorrectly lists the title of the invention for the application as "MICROWAVE APPLICATOR, PLASMA PROCESSING APPARATUS HAVING **THE** SAME, AND PLASMA PROCESSING METHOD" the word "**THE**" should be deleted. The title should read --"MICROWAVE APPLICATOR, PLASMA PROCESSING APPARATUS HAVING SAME, AND PLASMA PROCESSING METHOD--, as shown on the attached copy of the Official Filing Receipt.

Applicants respectfully request that the Office issue a corrected Official Filing Receipt indicating the above-referenced change to the title.

Any fees deemed necessitated by this Request may be charged to Deposit Account No. 06-1205.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



---

Attorney for Applicants  
Michael E. Kondoudis  
Registration No. 42,758

FITZPATRICK, CELLA, HARPER & SCINTO  
30 Rockefeller Plaza  
New York, New York 10112-3801  
Facsimile: (212) 218-2200

MEK/tmc  
DC\_MAIN 92626 v 1



## UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS  
UNITED STATES PATENT AND TRADEMARK OFFICE  
WASHINGTON, D.C. 20231  
www.uspto.gov

APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO.	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/816,359	03/26/2001	3742	1958	35.C13975 CIP	16	59	6

CONFIRMATION NO. 3496

## FILING RECEIPT



\*OC000000006133654\*

05514  
FITZPATRICK CELLA HARPER & SCINTO  
30 ROCKEFELLER PLAZA  
NEW YORK, NY 10112

Date Mailed: 05/31/2001

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

## Applicant(s)

Nobumasa Suzuki, Utsunomiya-shi, JAPAN;  
Shigenobu Yokoshima, Utsunomiya-shi, JAPAN;

## Domestic Priority data as claimed by applicant

THIS APPLICATION IS A CIP OF 09/426,774 10/26/1999

## Foreign Applications

JAPAN 2000-091709 03/29/2000  
JAPAN 10-308836 10/29/1998  
JAPAN 11-190400 07/05/1999

If Required, Foreign Filing License Granted 05/31/2001

Projected Publication Date: To Be Determined - pending completion of Missing Parts

Non-Publication Request: No

Early Publication Request: No

Title

RECEIVED  
APR 12 2002  
TECHNOLOGY CENTER 3700



Microwave applicator, plasma processing apparatus having ~~the~~ same, and plasma processing method

**Preliminary Class**

219

---

**Data entry by : ALHAIDARI, KHAIRIA**

**Team : OIPE**

**Date: 05/31/2001**

